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PATENT

Patent No.: 55933-067

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Isao HASEGAWA, et al.

Serial No.: 10/796,189

Filed: March 10, 2004

For: WIRING STRUCTURE FORMED IN CONTACT HOLE, MANUFACTURING METHOD THEREFOR, AND A DISPLAY APPARATUS HAVING THE SAME (AS AMENDED)

: Customer Number: 20277

: Confirmation Number: 2729

: Group Art Unit: 2821

: Examiner: not yet assigned

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each non-English language reference was cited in a corresponding foreign application office action and its relevance discussed therein. A copy of the foreign office actions, together with an English language version thereof, is attached for the Examiner's information.

10/796,189

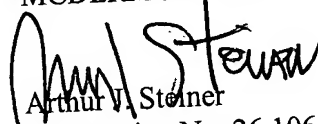
The Foreign Patent documents JP 2000-277607 (with English Abstract) and JP 2000-349298 (with English Abstract, previously cited in the Information Disclosure Statement, filed on 6/28/04) were cited in the July 2, 2004 Office Action in corresponding JP Application 2002-062670 (related Copending Application No. 10/383,058).

The Foreign Patent documents JP 10-170955, JP 11-111990 and JP 2000-236097, all with English Abstracts, were cited in the June 1, 2004 Office Action in corresponding JP Application 2002-059151 (related Copending Application No. 10/796,189).

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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SHEET 1 OF 1

INFORMATION DISCLOSURE
CITATION IN AN
APPLICATION

(PTO-1449)

ATTY. DOCKET NO.
65933-067SERIAL NO.
10/796,189APPLICANT
Isao HASEGAWA, et al.FILING DATE
March 10, 2004GROUP
2821

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US			
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FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes - Number 4 - Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation	
						Yes	No
		JP 2000-277607	10/06/2000	TOSHIBA CORP.		JAPAN (w/English Abstract)	
		JP 10-170955	06/26/1998	FUJITSU LTD		JAPAN (w/English Abstract)	
		JP 11-111990	04/23/1999	SANYO ELECTRIC CO LTD		JAPAN (w/English Abstract)	
		JP 2000-236097	08/29/2000	SEMICONDUCTOR ENERGY LAB CO LTD.		JAPAN (w/English Abstract)	

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.